

Electronic Acknowledgement Receipt

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Title of Invention:	Method of forming poly-silicon thin film transistors
First Named Inventor:	Chi-Lin Chen
Customer Number:	24504
Filer:	Daniel R. McClure
Filer Authorized By:	
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	00367101.pdf	262159	no	7

Warnings:	
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